



PATENT  
Docket No. 514242000110

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the application of:

Toshiyuki KAWAKAMI et al.

Serial No.: 10/815,847

Filing Date: April 2, 2004

For: METHOD OF FABRICATING NITRIDE  
SEMICONDUCTOR DEVICE

Examiner: Maria F. Guerrero

Group Art Unit: 2822

Conf. No.: 9482

**RESPONSE UNDER 37 CFR 1.111**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Action mailed September 20, 2005, please reconsider this application  
in light of the following remarks: